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OFGS File No: P/2699-28

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
EITOKU, Atsuro

New York, New York  
Date: September 6, 2005

Serial No.: 10/631,797

Group Art Unit: 1746

Date Filed: July 31, 2003

For: SUBSTRATE TREATMENT APPARATUS AND SUBSTRATE TREATMENT  
METHOD

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**STATUS INQUIRY LETTER**

Sir:

We filed the above application with the U. S. Patent and Trademark Office on July 31, 2003.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

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Attorney: James A. Finder  
OSTROLENK, FABER, GERB & SOFFEN  
1180 Avenue of the Americas  
New York, New York 10036-8403  
(212) 382-0700